

Initial Information Data Sheet

Inventor Information

Inventor One Given Name: Takayuki
Family Name: TOSHIMA
Name Suffix:
Postal Address Line One: c/o Tokyo Electron Kyushu Limited,
Postal Address Line Two: Process Development Center
Postal Address Line Three: 650, Mitsuzawa, Hosaka-cho
City: Nirasaki-shi, Yamanashi-ken
Country: JAPAN
Postal or Zip Code:
Citizenship Country: Japan

Inventor Two Given Name: Miyako
Family Name: YAMASAKA
Name Suffix:
Postal Address Line One: c/o Tokyo Electron Kyushu Limited,
Postal Address Line Two: Process Development Center
Postal Address Line Three: 650, Mitsuzawa, Hosaka-cho
City: Nirasaki-shi, Yamanashi-ken
Country: JAPAN
Postal or Zip Code:
Citizenship Country: Japan

Correspondence Information

Name Line One: David L. Fehrman
Name Line Two: Morrison & Foerster LLP
Address Line One: 555 W. 5th Street
Address Line Two: 35th Floor
City: Los Angeles
State or Province: CA
Postal or Zip Code: 90013-1024
Telephone: 213-892-5601
Fax: 213-892-5454
Electronic Mail: dfehrman@mofo.com

Application Information

Title Line One:	METHOD AND APPARATUS OF
Title Line Two:	PROCESSING SURFACE OF SUBSTRATE
Total Drawing Sheets:	10
Formal Drawings?:	Yes
Application Type:	non-provisional
Docket Number:	199372003600

Representative Information

Representative Customer Number:

Continuity Information

This application is a:

> Application One:

Filing Date:

which is a:

>>Application Two:

Filing Date:

which is a:

>>>Application Three:

Filing Date:

Prior Foreign Applications

Foreign Application One:	2000-320646
Filing Date:	October 20, 2000
Country:	Japan
Priority Claimed:	Yes

Assignee Information

Assignee:	TOKYO ELECTRON LIMITED
-----------	------------------------